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TO: Arnel C. Lavarias FAX #: (703) 872-9318
COMPANY: U.S. Patent & Trademark Office - Group Art Unit #2872
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REMARKS AND ENCLOSURES:

In re Appln. of: Kenneth Lloyd WESTRA and Brian MOORE
Serial No.: 09/758,715
Filed: January 11, 2001
For: A METHOD OF MAKING A HIGH REFLECTIVITY MICRO MIRROR
AND A MICRO MIRROR
Group Art Unit: 2872
Examiner: Arnel C. Lavarias
Docket: THOLAM P139US

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08/12/02

PATENT APPLICATION

#4 PB
8/21/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Serial no.	:	09/758,715
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The Commissioner of Patents and Trademarks
Washington D.C. 20231

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RESPONSE

Dear Sir:

This response is being filed in reply to the office action mailed July 15, 2002. In that action, the Examiner has required restriction under 35 U.S.C. 121 between the following groups of claims:

- I. Claims 1-24, drawn to a method of making a high reflectivity micro mirror, classified in class 216, subclass 2.
- II. Claims 25-62, drawn to a high reflectivity micro mirror, classified in class 359, subclass 838.

In the event that Group I (claims 1-24) is elected, an election of one of the following species is also required:

- | | |
|------------|--|
| Species 1: | a method of making a high reflectivity micromirror with the portion of the passage being removed being a passage extending parallel to the crystalline plane. Claims 1, 2, 7 and 21. |
| Species 2: | a method of making a high reflectivity micromirror with the portion of the passage being removed being an inlet passage and an outlet passage which intersect at the crystalline plane. Claims 1, 3, 8, 22 and 24. |
| Species 3: | a method of making a high reflectivity micromirror with the exposed portion of the crystalline plane becoming a part of an exterior surface of the body. Claims 1, 4, 18-23. |
| Species 4: | a method of making a high reflectivity micromirror with the exposed portion of the crystalline plane remaining positioned internally within the body. Claims 1 and 5. |